

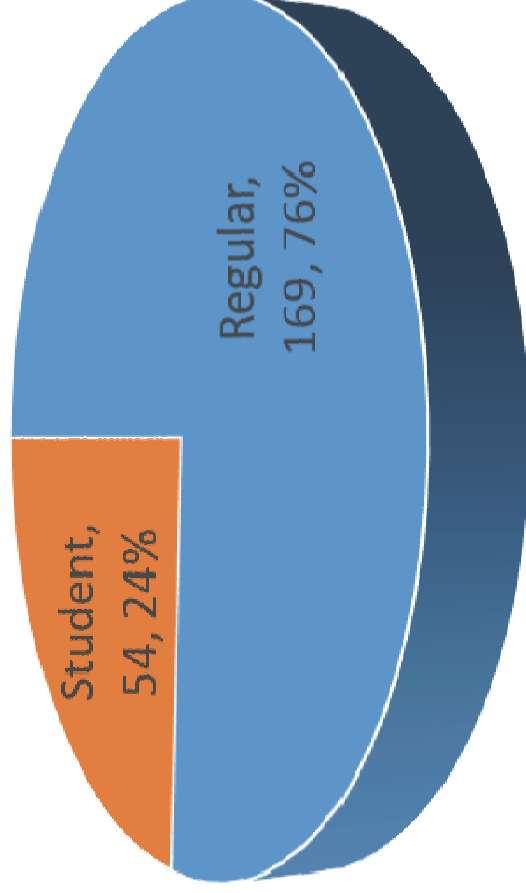


International Workshop on UV Materials and Devices 2017

IWUMD-2017

November 14-18, 2017
Fukuoka, Japan

Registration



Regular	178
Student	55
Total	233

Pre-registration (up to Nov.13) (on-site)

Regular (Early Bird)	143
Regular	26
Student(Early Bird)	48
Student	6
Total	223

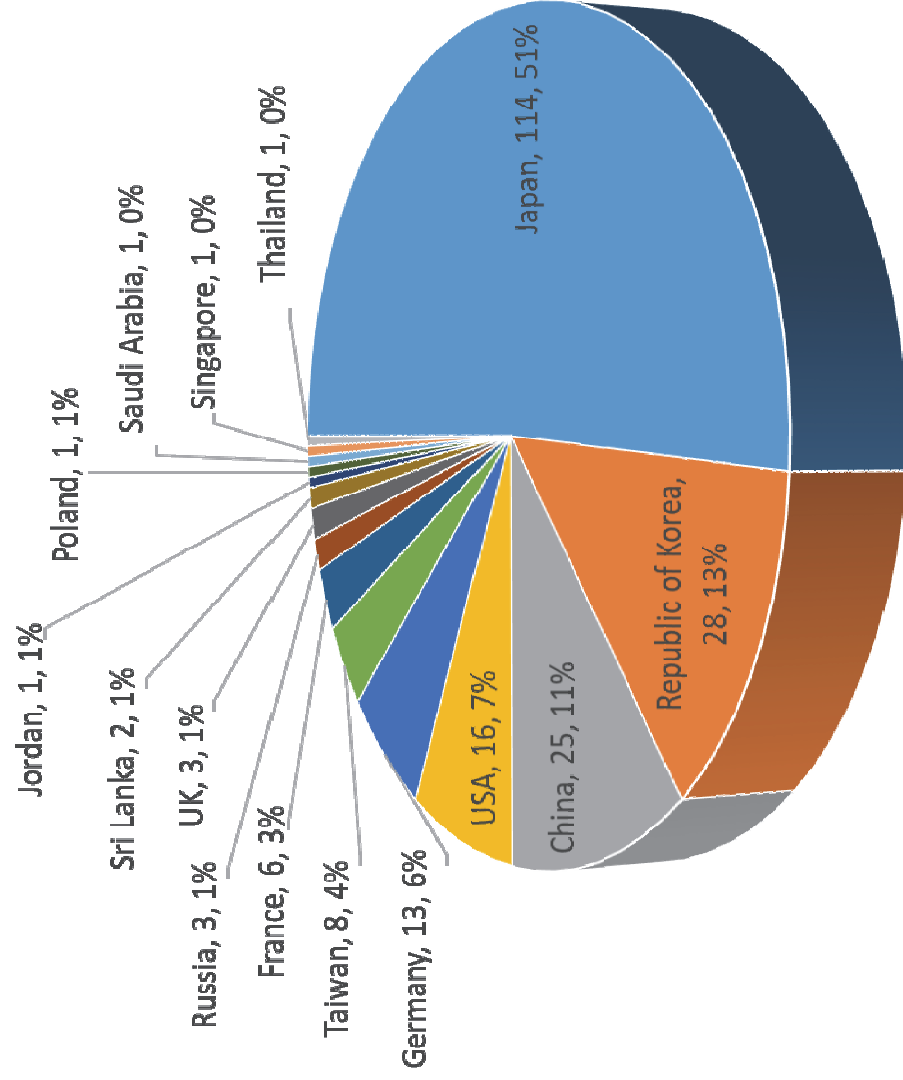


International Workshop on UV Materials and Devices 2017

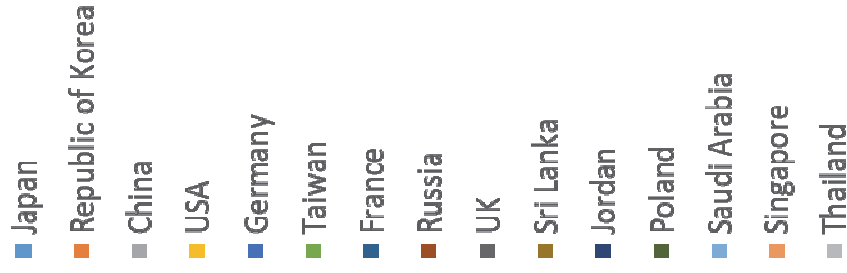
IWUMD-2017

November 14-18, 2017
Fukuoka, Japan

Registration



Japan	114
Republic of Korea	28
China	25
USA	16
Germany	13
Taiwan	8
France	6
Russia	3
UK	3
Sri Lanka	2
Jordan	1
Poland	1
Saudi Arabia	1
Singapore	1
Thailand	1
Total	223



Pre-registration (up to No.13)



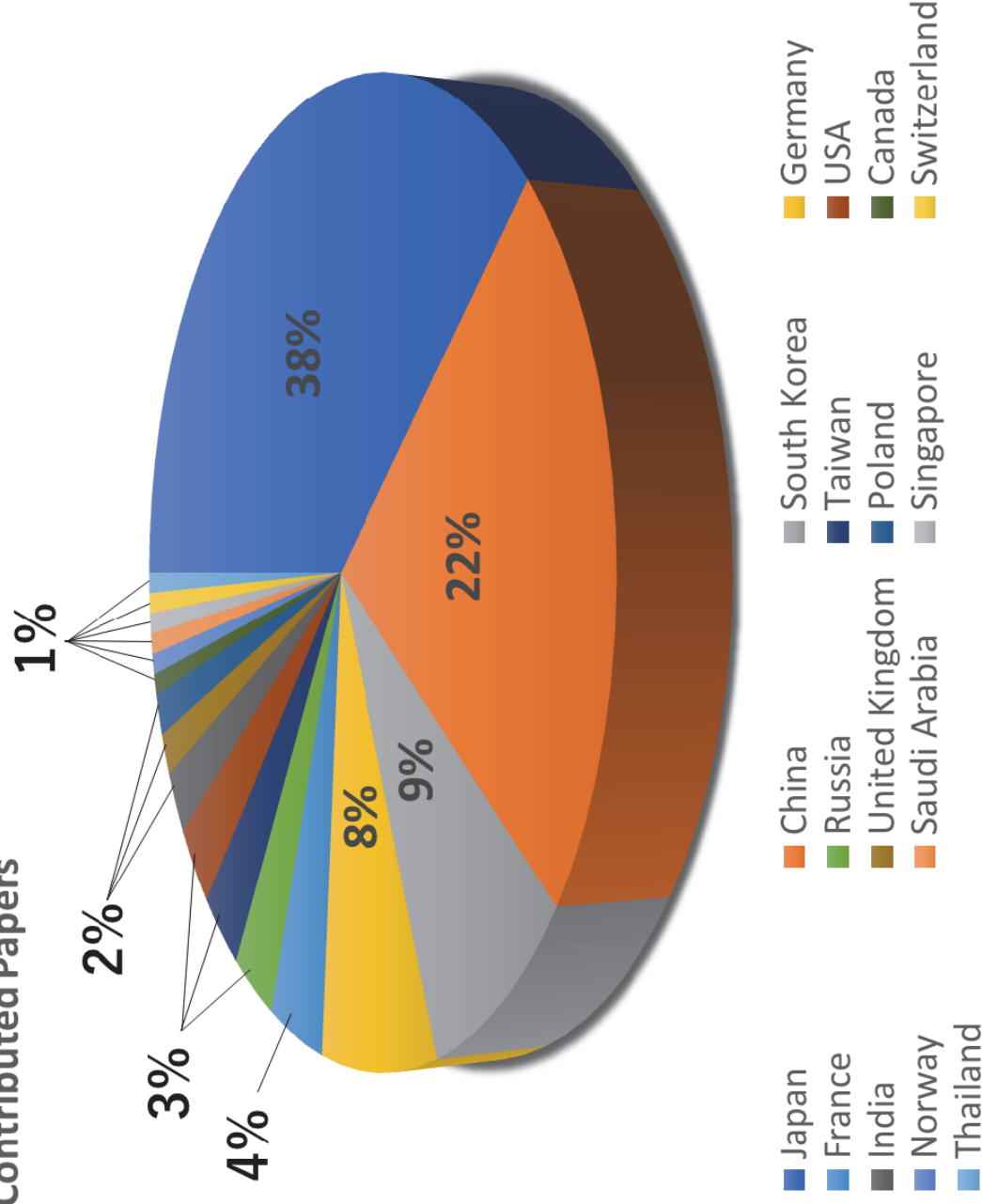
International Workshop on UV Materials and Devices 2017
IWUMD-2017
 November 14-18, 2017
 Fukuoka, Japan

Contributed papers statistics

total submission 127

Contributed Papers

Country	
Japan	48
China	28
South Korea	11
Germany	10
France	5
Russia	4
Taiwan	4
USA	4
India	3
United Kingdom	2
Poland	2
Canada	1
Norway	1
Saudi Arabia	1
Singapore	1
Switzerland	1
Thailand	1
Total	127





International Workshop on UV Materials and Devices 2017

November 14-18, 2017

Fukuoka, Japan

IWUMD-2017

Paper submission statistics

Growth	40	31%
Device	37	29%
Characterization	30	24%
BN and Oxides	20	16%
Total	127	100%

No show papers will be erased from final PRG.

We-P 2, 12, 16, 19, 20, 21, 30, 42

Th-P 20, 25, 27, 32, 36, 44, 45, 46, 50, 52

We will distribute the Final Program on-line.

Program details

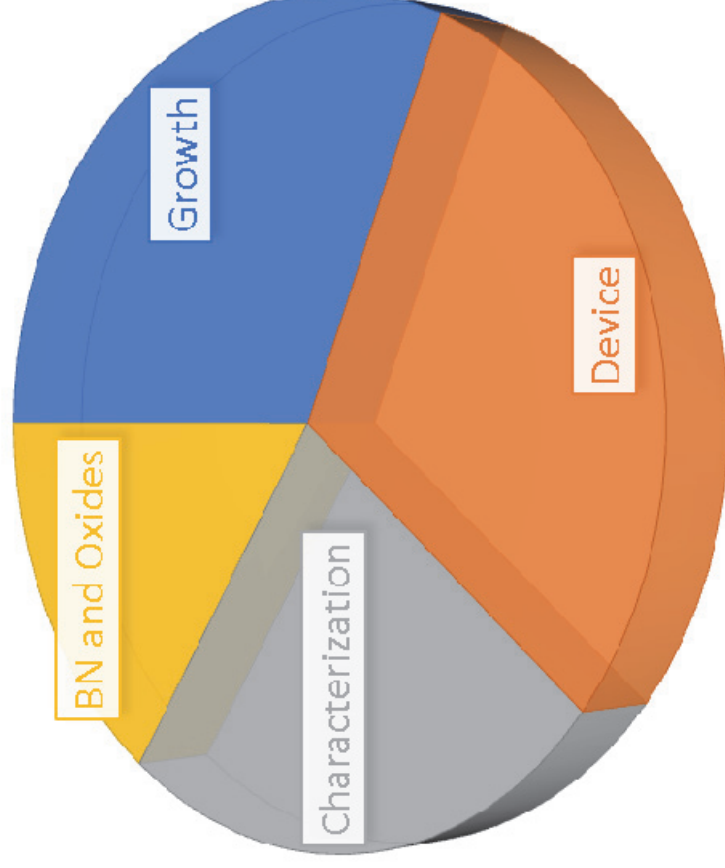
Plenary	2
Keynote	4
Invited	25

Contributed papers

Oral 22

Poster 101-18= 83

Papers presented 154-18=136





International Workshop on UV Materials and Devices 2017

November 14-18, 2017

Fukuoka, Japan

IWUMD-2017

Best Young Scientist Award

Meng Chen

Nutthapong Discharoen

Xumin Gao

Junya Hakamata

Yusuke Hayashi

Sehee Jeong

Yuta Kawase

Hisanori Kojima

Kevin Lee

Yu Okamoto

Kanako Shojiki

Nao Takekawa

Thi Quynh Phuong Vuong

Mingxing Wang

Shiyu Xiao

Akira Yoshikawa